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Docket No.: 070759-0042

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Yasuhiro WATANABE, et al. : Confirmation Number: 4678

Application No.: 10/575,899 : Group Art Unit: 2814

Filed: April 14, 2006 : Examiner: Long Pham

For: SEMICONDUCTOR LASER DEVICE AND MANUFACTURING METHOD THEREOF

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 11, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.